



Attorney's Docket No. 5649-917

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: Chung et al.

Confirmation No.: 6119

Serial No.: 10/043,027

Group Art Unit: 2813

Filed: January 9, 2002

Examiner: William C. Vesperman

For: METHODS OF FORMING AN INTEGRATED CIRCUIT CAPACITOR IN WHICH
A METAL PREPROCESSED LAYER IS FORMED ON AN ELECTRODE
THEREOF

Date: June 18, 2004

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE (37 C.F.R. 1.312)

Sir:

Applicants provide the present Amendment responsive to the Notice of Allowance" of March 26, 2004. Applicants provide the present Amendment pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.